



PATENT  
81716.0122

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:  
Isamu AKASAKI et al.  
Serial No: 10/810,309  
Filed: March 26, 2004  
For: Semiconductor Apparatus, Method for  
Growing Nitride Semiconductor and Method  
for Producing Semiconductor Apparatus

Art Unit: 2811

Examiner: Not assigned

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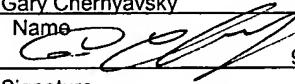
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**PETITION FOR EXTENSION OF TIME**

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Dear Sir:

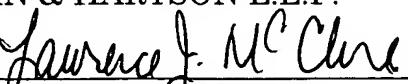
In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the Commissioner for a two-month extension of time extending to October 7, 2004, the period for response to the Notice to File Missing Parts of Application dated June 7, 2004. The check in the amount of \$420.00 is enclosed. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: September 20, 2004

By:   
Lawrence J. McClure  
Registration No. 44,228  
Attorney for Applicant(s)

500 South Grand Avenue, Suite 1900  
Los Angeles, California 90071  
Phone: 213-337-6700  
Fax: 213-337-6701